

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Jerome M. Eldridge et al.

Title: ATOMIC LAYER DEPOSITION OF METAL OXIDE AND/OR LOW ASYMMETRICAL
TUNNEL BARRIER INTERPOLY INSULATORS

Docket No.: 1303.045US1

Serial No.: 10/081,818

Filed: February 20, 2002

Due Date: November 8, 2008

Examiner: Tu-Tu Ho

Group Art Unit: 2818

Customer No.: 73115

Confirmation No.: 3148

Notice of Allowance Date: August 8, 2008

Mail Stop Issue Fee

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

We are transmitting herewith the following:

- ☒ Authorization to charge Deposit 19-0743 in the amount of \$110.00 to cover the issue fee increase.
- ☒ Issue Fee Transmittal (Form PTOL-85).
- ☒ Request to Apply Previously Paid Issue Fee (1 pg.)
- ☒ Communication Re: Fee Address (1 page).
- ☒ Communication Concerning Related Applications (1 pg)
- ☒ Supplemental Information Disclosure Statement Under CFR 1.97(i) (3 pgs)

Please charge any additional required fees or credit overpayment to Deposit Account No. 19-0743.

SCHWEGMAN, LUNDBERG & WOESSNER, P.A.

By 

Customer No.: 73115

Timothy B. Clise

TBC:CMG:kerl

Reg. No. 40,957

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being filed using the USPTO's electronic filing system EFS-Web, and is addressed to: Mail Stop Issue Fee, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on this 7 day of November, 2008.

KATHLEEN E. BOTHEROCK
Name

Kathleen E. Botherock
Signature